

*#29*  
*Condit JX*  
*7/12-11-98*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hidehiko KIRA et al.

Serial No. 08/897,953

Filed: July 24, 1997

For: METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE



Group Art Unit: 2814

Examiner: David E. GRAYBILL

*Spruill*  
*1-20-99*

*DPA 1-16-99*  
*DO NOT ROUTER*  
*12-28-98*

**RESPONSE UNDER 37 C.F.R. §1.116**  
- EXPEDITED RESPONSE -  
**GROUP ART UNIT 2814**

**BOX AF**

Assistant Commissioner of Patents  
Washington, D. C. 20231

*RECEIVED*  
TECHNOLOGY CENTER 2000  
08 DEC 19 PM 2:14  
December 7, 1998

Sir:

In response to the Office Action dated July 6, 1998, please amend this application as follows:

**IN THE DRAWINGS:**

The applicants respectfully submit herewith a Request for Approval of Drawings. Corrections along with proposed drawing corrections to Figure 3, marked in red ink.